

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Tatsuya ARAO et al.)
Japanese Priority Application No. 2000-140592) Attn: Applications
Japanese Priority Date: May 12, 2000) Branch
For: SEMICONDUCTOR DEVICE AND) Date: April 5, 2001
MANUFACTURING METHOD THEREOF)



INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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